Weighte HIGH TEMPERATURE MINIATURE PRESSURE TRANSDUCER

XCE-080 SERIES

- Wide Temperature Capability -65°F To 525°F
- Ideal For Turbine Engine Probes and Wind Tunnel Applications
- 50 Year History Of Successful Applications In Wind Tunnel And Flight Test Programs
- Patented Silicon on Silicon Integrated Sensor VIS[®]
- Size And Shape Ideal For Incorporation In User Designed Probes
- Excellent Static And Dynamic Performance

The XCE-080 Series allow for a very rugged package suited for probes, pressure rakes and other similar test set ups. This transducer is well suited for both dynamic and static pressure measurements in benign or harsh environments. Its wide operating temperature range (-65°F to +525°F) makes it ideal for numerous applications in Aerospace and other areas of industry.

Kulite recommends the KSC Series of signal conditioners to maximize the measurement capability of the XCE-080 transducer.



080 (2.0) "B" SCREEN STANDARD "M" SCREEN OPTIONAL .016 0.0. X 1" LONG (41 X 25.4) FOR GAGE & DIFFERENTIAL UNITS 010 DIA. X 1" (2.8 X 20 LONG FOR 36 AWG L 300°F MAX (150°C) .016 0.0. X 1" LONG (41 X 25.4) FOR GAGE & DIFFERENTIAL UNITS 010 DIA. X 1" (2.8 X 20 LONG FOR 36 AWG L 300°F MAX (150°C) .006 FOR 36 AWG L 300°F MAX (150°C) 010 DIA. X 1" (2.8 X 20 LONG FOR 36 AWG L 300°F MAX (150°C) .006 FOR 36 AWG L 300°F MAX (150°C) 010 DIA. X 1" (2.8 X 20 LONG FOR 36 AWG L 300°F MAX (150°C) .006 FOR 36 AWG L 300°F MAX (150°C) 010 DIA. X 1" (2.8 X 20 LONG FOR 36 AWG L 300°F MAX (150°C) .006 FOR 36 AWG L 300°F MAX (150°C) 010 DIA. X 1" (2.8 X 20 LONG FOR 36 AWG L 300°F MAX (150°C) .006 FOR 36 AWG L 300°F MAX (150°C) 010 DIA. X 1" (2.8 X 20 LONG FOR 36 AWG L 300°F MAX (150°C) .000 FOR 36 AWG L 300°F MAX (150°C) 010 DIA. X 1" (2.8 X 20 LONG FOR 36 AWG L 300°F MAX (150°C) .000 FOR 36 AWG L 300°F MAX (150°C) 010 DIA. X 1" (2.8 X 20 LONG FOR 36 AWG L 300°F MAX (150°C) .000 FOR 36 AWG L 4 LEADS TEFLON INSULATED 4 LEADS TE	25.4)	
	35 70 BAR 500 1000 PSI	
	Sealed Gage	
Over Pressure 2 Times Rated Pressure		
Burst Pressure 3 Times Rated Pressure		
Z Pressure Media All Nonconductive, Noncorrosive Liquids or Gases		
Rated Electrical Excitation 10 VDC/AC		
Maximum Electrical Excitation 12 VDC/AC		
Input Impedance 1000 Ohms (Min.)	1000 Ohms (Min.)	
Output Impedance 1000 Ohms (Nom.)		
Full Scale Output (FSO) 100 mV (Nom.)		
Residual Unbalance ± 5 mV (Typ.)		
Combined Non-Linearity, Hysteresis and Repeatability ± 0.1% FSO BFSL (Typ.), ± 0.5% FSO (Max.)		
and Repeatability ±0.1% FSO BFSL (19), ±0.5% FSO (Wax.) Resolution Infinitesimal		
Natural Frequency of Sensor1501752002403003805507Without Screen (KHz) (Typ.)	00 1000	
Acceleration Sensitivity % FS/g Perpendicular 1.5x10 ⁻³ 1.0x10 ⁻³ 6.5x10 ⁻⁴ 5.0x10 ⁻⁴ 3.0x10 ⁻⁴ 1.5x10 ⁻⁴ 1.0x10 ⁻⁴ 6.0x	0x10 ⁻⁵ 4.5x10 ⁻⁵	
Insulation Resistance 100 Megohm Min. @ 50 VDC		
-65°F to +525°F (-55°C to +273°C) Sensor Only		
Compensated Temperature Range 80°F to +450°F (25°C to +235°C) Sensor Only		
Compensated Temperature Range 80°F to +450°F (25°C to +235°C) Sensor Only Thermal Zero Shift ± 1% FS/100°F (Typ.) Thermal Sensitivity Shift ± 1% /100°F (Typ.) Mechanical Shock 20g Half Sine Wave 11 msec. Duration		
Thermal Sensitivity Shift ± 1% /100°F (Typ.)		
Mechanical Shock 20g Half Sine Wave 11 msec. Duration		
Linear Vibration 20g Peak, Sine 10 to 2000 Hz		
Lectrical Connection 4 Leads 36 AWG 36" Long Weight .4 Gram (Nom.) Excluding Module and Leads Pressure Sensing Principle Fully Active Four Arm Wheatstone Bridge Dielectrically Isolated Silicon on Silicon		
Weight .4 Gram (Nom.) Excluding Module and Leads		
E Pressure Sensing Principle Fully Active Four Arm Wheatstone Bridge Dielectrically Isolated Silicon on Silicon		

Note: Custom pressure ranges, accuracies and mechanical configurations available. Dimensions are in inches. Dimensions in parenthesis are in millimeters. All dimensions nominal. (I) Continuous development and refinement of our products may result in specification changes without notice. Copyright © 2014 Kulite Semiconductor Products, Inc. All Rights Reserved. Kulite miniature pressure transducers are intended for use in test and research and development programs and are not necessarily designed to be used in production applications. For products designed to be used in production programs, please consult the factory.